

<b>Notice of References Cited</b>	Application/Control No. 09/992,924	Applicant(s)/Patent Under Reexamination WEIMERSKIRCH, ANDRE	
	Examiner Shin-Hon Chen	Art Unit 2131	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0065621	04-2003	Kambayashi et al.	705/57
	B	US-			
	C	US-			
	D	US-			
	E	US-			
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**FOREIGN PATENT DOCUMENTS**

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